



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shin-Hsin Chang :  
Serial No. : 10/623,550 : Group Art Unit #1732  
Filed : 22 July 2003 : Examiner: D. T. Beck  
Title : MANUFACTURING METHOD FOR  
POLYMER CHIPS CONTAINING METAL  
OR METAL OXIDE NANOPARTICLES  
COMPONENTS

RESPONSE TO RESTRICTION REQUIREMENT  
AND AMENDMENT

Mail Stop NO FEE  
Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant, by the undersigned attorney hereby responds to the outstanding  
Official Action dated 29 April 2005 which is a Restriction Requirement. Please  
amend the above-referenced patent application as follows:

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper.